

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Freese et al. Confirmation No.: 8346
Serial No.: 10/661,917 Examiner: Daborah Chacko Davis
Filed: September 11, 2003 Group Art Unit: 1795
For: METHODS FOR MASTERING MICROSTRUCTURES THROUGH A SUBSTRATE
USING NEGATIVE PHOTORESIST

September 13, 2010

Mail Stop Issue Fee
Commissioner for Patents
Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER ALLOWANCE PURSUANT TO 37 CFR 1.312

Sir:

The present Amendment is being filed in response to the Notice of Allowance mailed September 7, 2010.

If any extension of time for the accompanying response or submission is required, please consider this a petition therefor. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

Amendments to the title begin on Page 2 of this paper.

Remarks begin on Page 3 of this paper.